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| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. | |
|--|-----------------|----------------------|------------------------|------------------|--|
| 10/710,841 | 08/06/2004 | Masuhiro Natsuhara | 39.053 | 4840 | |
| 29453 | 7590 10/23/2006 | | EXAM | EXAMINER | |
| JUDGE & MURAKAMI IP ASSOCIATES DOJIMIA BUILDING, 7TH FLOOR | | | KACKAR | KACKAR, RAM N | |
| 6-8 NISHITEMMA 2-CHOME, KITA-KU | | KU | ART UNIT | PAPER NUMBER | |
| OSAKA-SHI | • | | 1763 | | |
| JAPAN | | | DATE MAILED: 10/23/200 | 6 | |

Please find below and/or attached an Office communication concerning this application or proceeding.

| | | Application No. | Applicant(s) | |
|--|--|--|--|--|
| Office Action Summary | | 10/710,841 | NATSUHARA ET AL. | |
| | | Examiner | Art Unit | |
| | | Ram N. Kackar | 1763 | |
| | The MAILING DATE of this communication app | pears on the cover sheet with the | correspondence address | |
| Period fo | • • | | | |
| WHIC - Exte after - If NC - Failt Any | IORTENED STATUTORY PERIOD FOR REPL' CHEVER IS LONGER, FROM THE MAILING D. ensions of time may be available under the provisions of 37 CFR 1.1 r SIX (6) MONTHS from the mailing date of this communication. O period for reply is specified above, the maximum statutory period of ure to reply within the set or extended period for reply will, by statute reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b). | ATE OF THIS COMMUNICATIO 36(a). In no event, however, may a reply be ti will apply and will expire SIX (6) MONTHS from t, cause the application to become ABANDON | N. imely filed in the mailing date of this communication. ED (35 U.S.C. § 133). | |
| Status | | | | |
| 1) 又 | Responsive to communication(s) filed on <u>06 A</u> | uaust 2004. | | |
| | | action is non-final. | | |
| 3)[| Since this application is in condition for allowa | nce except for formal matters, pr | osecution as to the merits is | |
| | closed in accordance with the practice under E | Ex parte Quayle, 1935 C.D. 11, 4 | 53 O.G. 213. | |
| Disposit | ion of Claims | | | |
| • | Claim(s) <u>1-5</u> is/are pending in the application. | | | |
| .,ح | 4a) Of the above claim(s) is/are withdraw | wn from consideration. | | |
| 5)[| Claim(s) is/are allowed. | | | |
| 6)⊠ | Claim(s) <u>1-5</u> is/are rejected. | | | |
| 7) | Claim(s) is/are objected to. | | | |
| 8)[| Claim(s) are subject to restriction and/o | r election requirement. | | |
| Applicat | ion Papers | | | |
| 9)[| The specification is objected to by the Examine | er. | | |
| | The drawing(s) filed on is/are: a) acc | | Examiner. | |
| | Applicant may not request that any objection to the | drawing(s) be held in abeyance. Se | e 37 CFR 1.85(a). | |
| | Replacement drawing sheet(s) including the correct | ion is required if the drawing(s) is ob | ojected to. See 37 CFR 1.121(d). | |
| 11) | The oath or declaration is objected to by the Ex | caminer. Note the attached Office | e Action or form PTO-152. | |
| Priority (| under 35 U.S.C. § 119 | | | |
| | Acknowledgment is made of a claim for foreign | priority under 35 U.S.C. § 119(a | a)-(d) or (f). | |
| a) | ⊠ All b) ☐ Some * c) ☐ None of: | | | |
| | 1. Certified copies of the priority document | | | |
| | 2. Certified copies of the priority document | | | |
| | Copies of the certified copies of the prior application from the International Bureau | | ed in this National Stage | |
| * (| See the attached detailed Office action for a list | • | ed | |
| | | | | |
| Attachmen | nt(s) | | | |
| | ce of References Cited (PTO-892) | 4) Interview Summary | | |
| | ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO/SB/08) | Paper No(s)/Mail D 5) Notice of Informal R | | |
| | er No(s)/Mail Date | 6) Other: | and the second s | |

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

2. Claims 1-5 are rejected under 35 U.S.C. 102(b) as being anticipated by Tamura et al (US 5792304).

Tamura et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 13-2 and Col 17-line 29- line 37), a vertically movable pedestal (63 and Col 17-line 53 to Col 18 line 4), support pieces mounted to pedestal (Fig 9 and Fig 13), a hermetic bellows seal between pedestal and chamber (50) and lift pins to load /unload substrates (19).

3. Claims 1-5 are rejected under 35 U.S.C. 102(b) as being anticipated by Aruga et al (US 5688331).

Aruga et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 6-39), a vertically movable pedestal (95 and 61), support pieces mounted to pedestal (Fig 6), a hermetic bellows seal between pedestal and chamber (37) and lift pins to load /unload substrates (Col 5 lines 15-20 and Col 11 lines 62-68).

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4. Claims 1-5 are rejected under 35 U.S.C. 102(e) as being anticipated by Brown et al (US 20030029568).

Brown et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 2 and Paragraphs 39-42), a vertically movable pedestal, support pieces mounted to pedestal (Fig 2), a hermetic bellows seal between pedestal and chamber (252) and lift pins to load /unload substrates (290).

Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Wafer holder to hold and transport substrates with vertically movable pedestal, a hermetic bellows seal between pedestal and chamber and lift pins to load /unload substrates are also disclosed by Schieve et al (2004/0177813), Yudovsky et al (2003/0136520) and others.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent

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Application Information Retrieval (PAIR) system. Status information for published applications

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like assistance from a USPTO Customer Service Representative or access to the automated

information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Ram Kackar

Primary Examiner AU 1763